

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Attorney Docket No. 2006\_0772A  
Mitsuhiro OKUNE et al. : **Confirmation No. 1821**  
Serial No. 10/581,256 : Group Art Unit 1792  
Filed May 31, 2006 : Examiner Mahmoud Dahimene  
PLASMA ETCHING METHOD : **Mail Stop: AF**

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**AMENDMENT AFTER FINAL**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

DO NOT ENTER: /M.D./ (10/05/2010)

Sir:

Responsive to the final Office Action dated August 5, 2010, the Applicants herein request entry and consideration of the following amendments and remarks.